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**RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE - EXAMINING GROUP 2872**

Attorney Docket No.: 5649-1275

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Oh et al.  
Serial No.: 10/830,214  
Filed: April 22, 2004

Confirmation No.: 9024  
Examiner: Joannie A. Garcia  
Art Unit: 2823

For: **METHODS OF FORMING MIM TYPE CAPACITOR STRUCTURES  
USING LOW TEMPERATURE PLASMA PROCESSING**

August 25, 2005

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL**

Sir:

This Amendment After Final is responsive to the Final Official Action of July 12, 2005. It is not believed that an extension of time and/or additional fee(s), including fees for additional claims, are required, beyond those that may otherwise be provided for in documents accompanying this paper. In the event, however, that an extension of time is necessary to allow consideration of this paper, such an extension is hereby petitioned under 37 C.F.R. §1.136(a). Any additional fees believed to be due in connection with this paper may be charged to our Deposit Account No. 50-0220. If any informal matters arise the Examiner is encouraged to contact the undersigned by telephone at (919) 854-1400.

Amendments to the Claims begin on Page 2.

Remarks begin on page 6.